

Please amend claims 1 and 5 as follows:

*Sub C* >  
B1 1. (Twice Amended) An organic EL device comprising:

a lower electrode formed on a substrate;

an organic EL layer formed on the lower electrode;

an upper electrode formed on the organic EL layer;

a sealing member for sealing said lower electrode, organic EL layer and upper electrode on said substrate so that they are covered with the sealing member, wherein said sealing member is further comprised of an aluminum material and an absorbing material, which is made of a porous aluminum oxide layer formed by anodic oxidation of said aluminum material on an inner surface thereof, for absorbing an impurity.

B2 5. (Amended) An organic EL device according to claim 1, wherein said

aluminum sheet is formed in such a manner that a surface of said aluminum oxide layer is

subjected to gas flow-out treatment in vacuum, and thereafter said lower electrode, organic EL

layer and upper electrode are sealed on the substrate in an atmosphere of inert gas.